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## \*BIBDATASHEET\*

## Bib Data Sheet

CONFIRMATION NO. 1045

SERIAL NUMBER 10/775,515	FILING DATE 02/10/2004 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. YOR920010308US2 (16315A)
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PD

\*\* CONTINUING DATA ..... YES .....

This application is a DIV of 09/838,892 04/20/2001 PAT 6,750,119

PD

\*\* FOREIGN APPLICATIONS ..... NONE .....

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/06/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	NY	11	13	1
Verified and Acknowledged	<i>Yang Chu</i> <i>PD</i> Examiner's Signature Initials				

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## TITLE

Epitaxial and polycrystalline growth of Si<sub>1-x-y</sub>Ge<sub>x</sub>C<sub>y</sub> and Si<sub>1-y</sub>C<sub>y</sub> alloy layers on Si by UHV-CVD

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other
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